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** CONTINUING DATA

MK (verified)

This application is a DIV of 10/396,407 03/26/2003 PAT 6,709,531
 which is a DIV of 09/784,200 02/16/2001 PAT 6,579,382

** FOREIGN APPLICATIONS

MK (verified)

JAPAN P2000-39683 02/17/2000

JAPAN P2000-297441 09/28/2000

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

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Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY JAPAN	SHEETS DRAWING 18	TOTAL CLAIMS 20	INDEPENDENT CLAIMS 2
35 USC 119 (a-d) conditions met <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance				
Verified and Acknowledged	Examiner's Signature <i>[Signature]</i>	Initials <i>MK</i>		

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TITLE

Chemical liquid processing apparatus for processing a substrate and the method thereof

☐ All Fees